

The Influence of Scanning Parameters on CMM Measurements

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Introduction

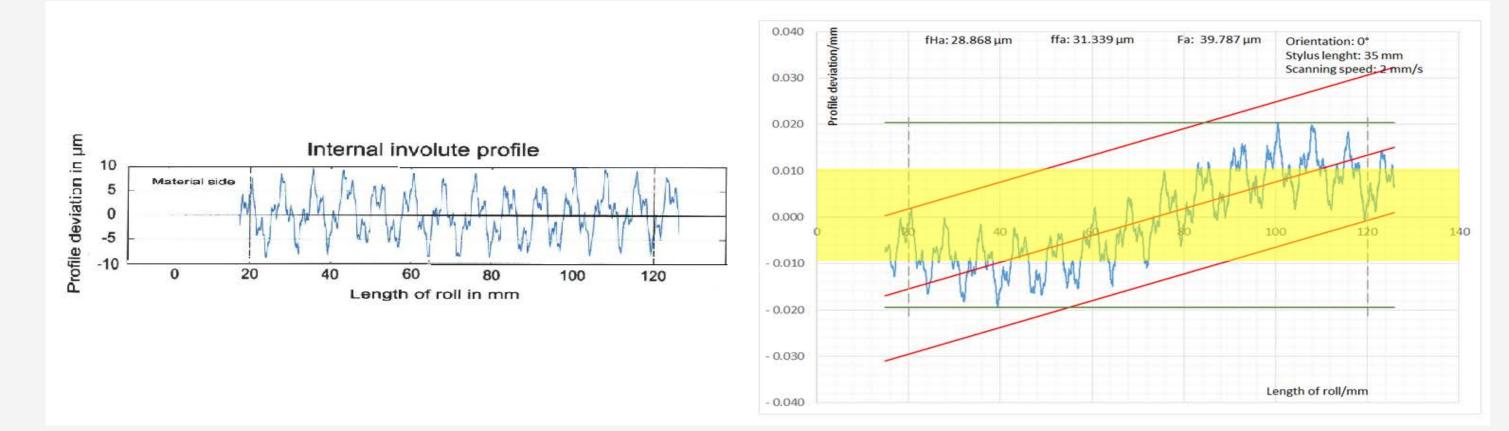
This work shows the results of Deliverable 5.2.3 - JRP ENG56 DriveTrain about "validation of measurement strategies and determination of achievable measurement uncertainty in industrial *environment*". Deliverable refers to investigation of dynamic behavior of probing systems due to scanning measurement at CMM of two standard involute profiles, both superposed with a certain waviness. INRIM investigated the influence of scanning parameters such as different scanning speeds, workpiece orientations inside the measurement volume and stylus lengths. Measurement results have been analyzed in order to evaluate the profile deviations (F_a , f_{fa} and f_{Ha}) according to ISO 1328-1:2013 and the influence due to the scanning measurement parameters on these results. Moreover, a spectral analysis has been performed using FFT method and the three main components of the spectrum have been calibrated in terms of wavelength and amplitude.

The measurement standard SAFT 2w

The standard SAFT 2w is a plate with a diameter of 290 mm and a thickness of 20 mm, with 2 polished references on the border (a circle and a plan) in order to determine the reference axis of the workpiece. The standard embodies an internal and an external involute profile both superposed with a certain waviness. The profiles have been manufactured with a wire-cut EDM

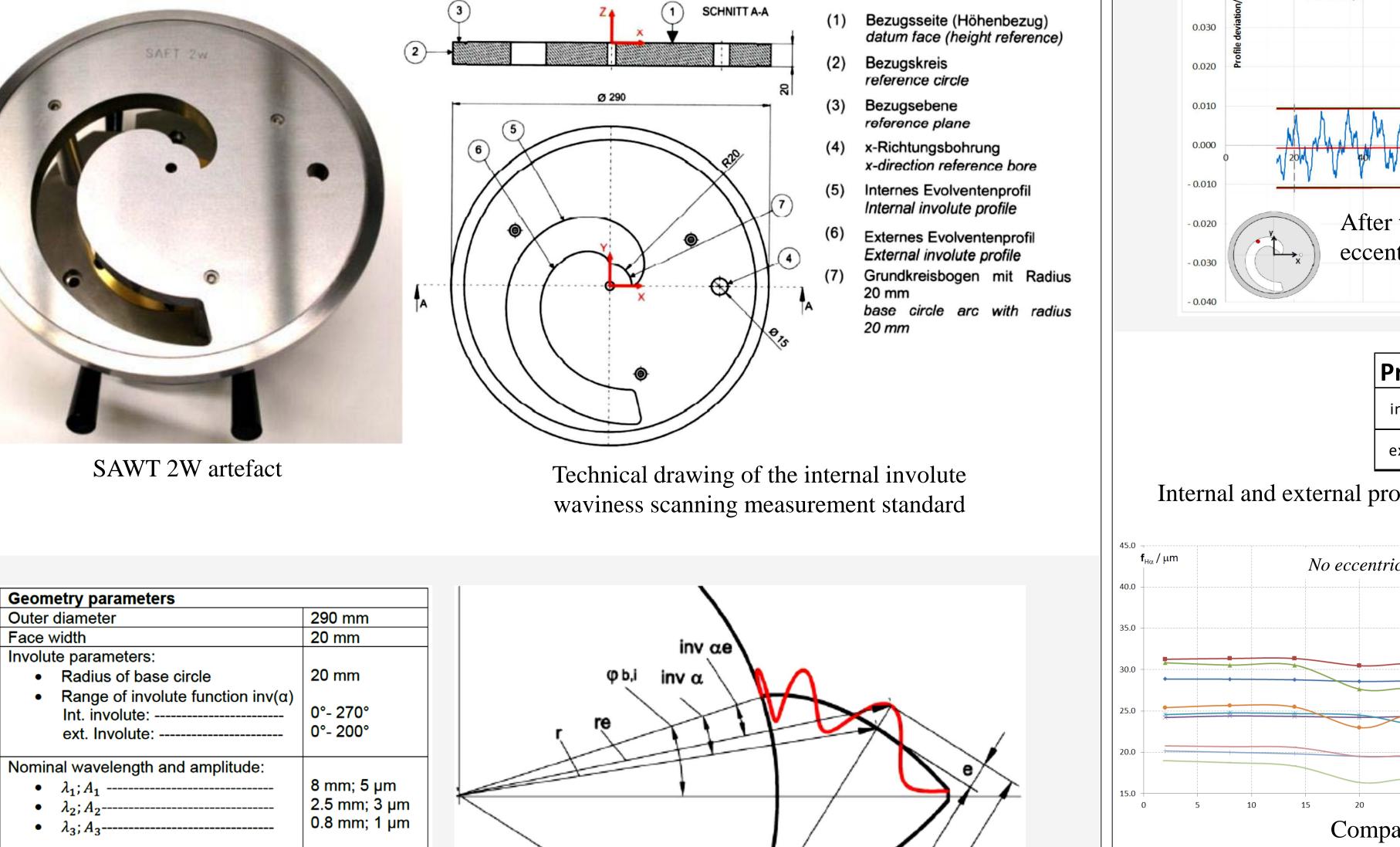
Scanning measurement results and data analysis

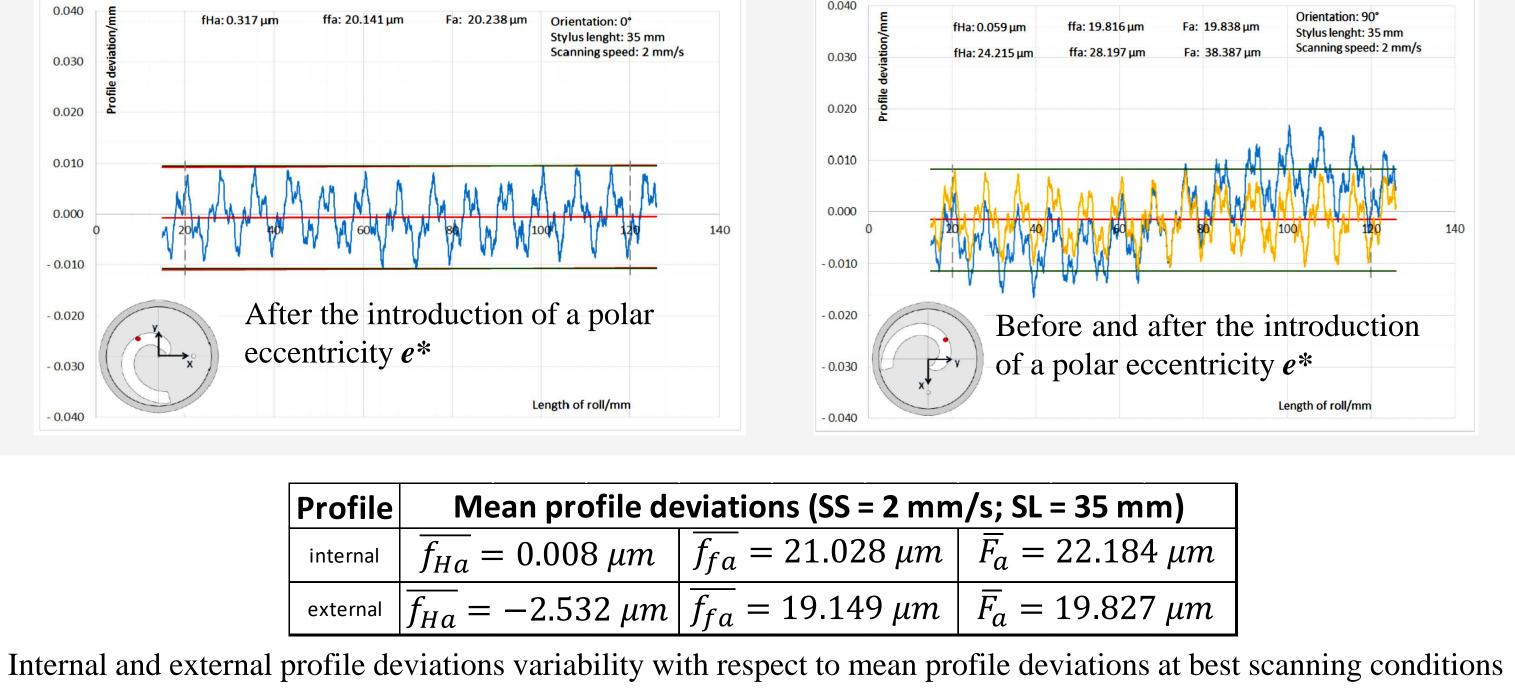
A total of 270 measurement profiles have been performed. From the measurement data the profiles have been calculated as function of roll length, then the theoretical involute was subtracted from data. A first evaluation of computed data evidenced the presence of an unexpected periodic deviation of the profile that seemed to reveal some eccentricity. in particular a polar eccentricity e* has been introduced in order to eliminate the sinusoidal behaviour and its application has been observed at different workpiece orientations.

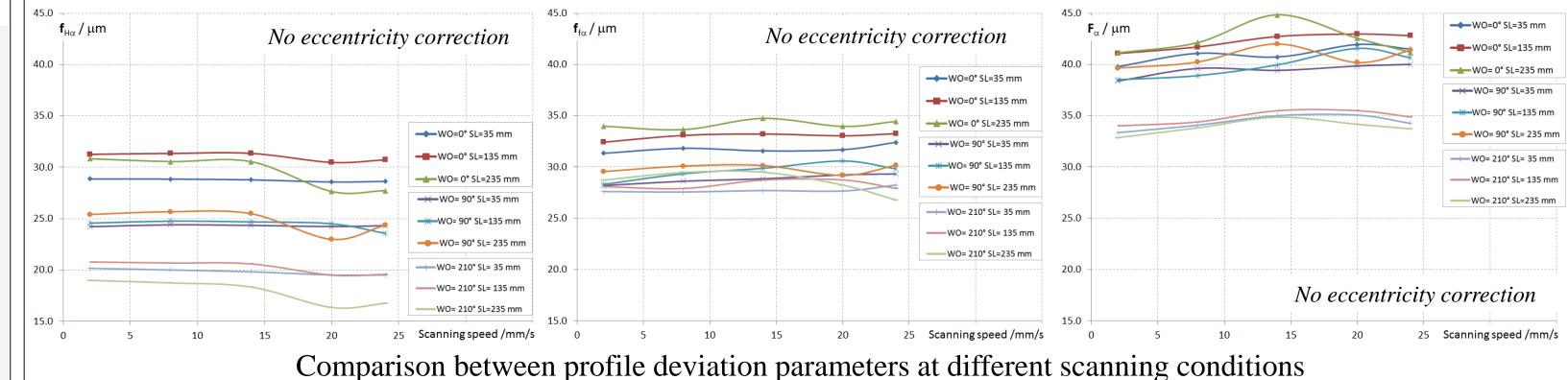


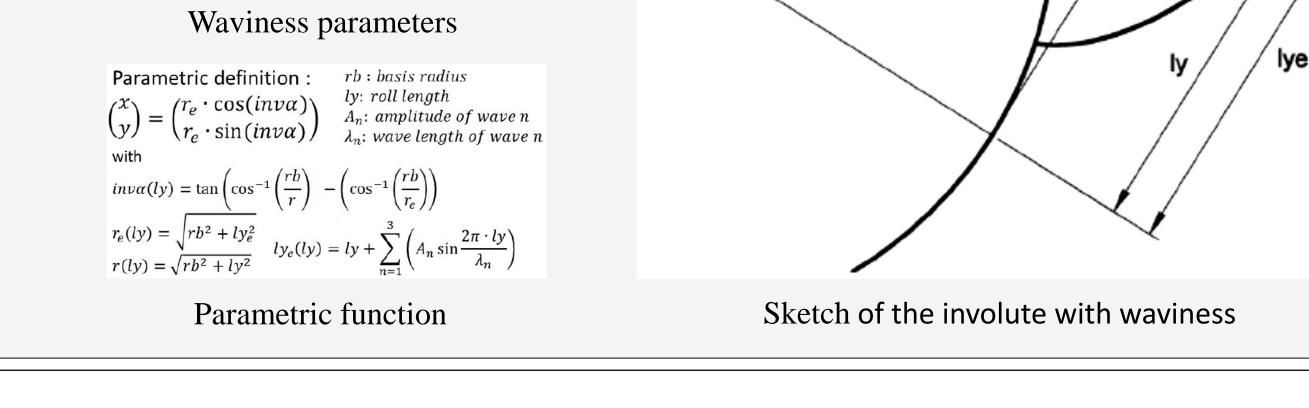
Profile deviation: from PTB certificate (left), from INRiM scanned data points (right)

machine. The machining data points have been obtained by using a parametric function.







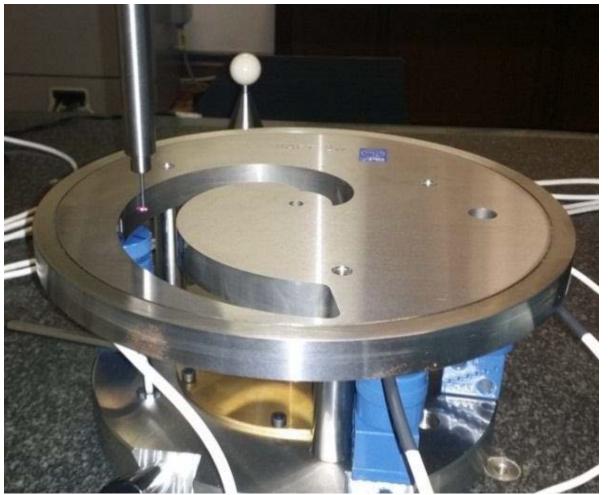


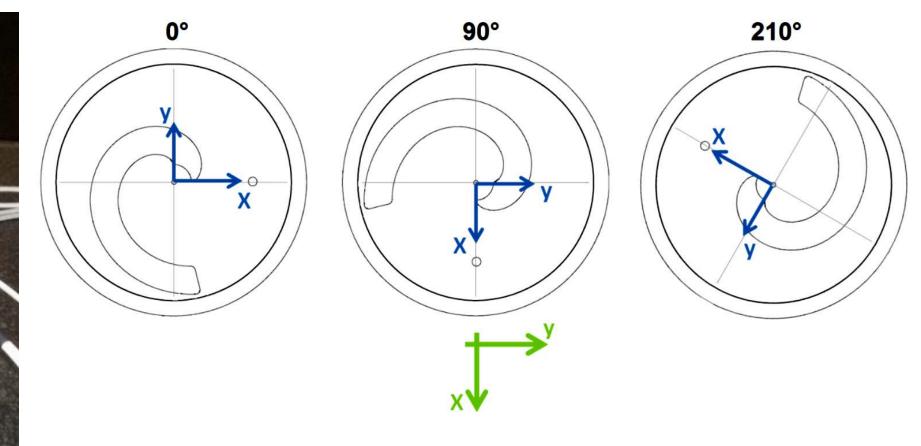
Experimental setup and plan of measurement

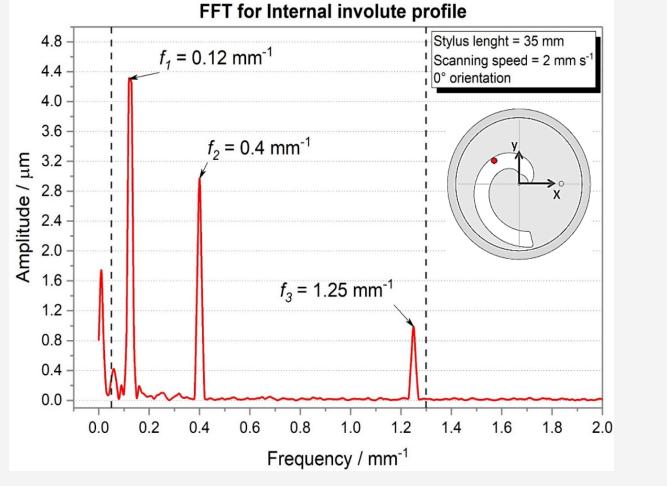
- Measuring volume: 12 x 10 x 7 dm³;
- $\text{EMP}_{\text{E}} = 0.6 \,\mu\text{m} + 1.7 \cdot 10^{-6} \,\text{L};$
- $P_{FTU} = 0.6 \ \mu m;$
- Resolution= $0.05 \,\mu m \,(20 \,\text{points/mm});$
- Stylus model: Leitz trax (tip diameter : 3 mm).

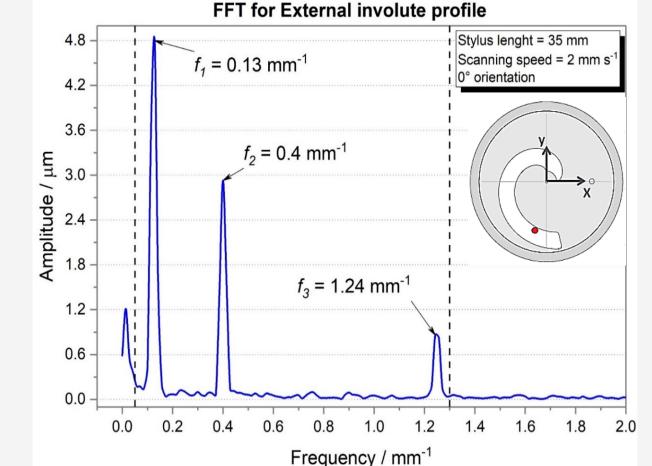
One face of SAFT 2w was equipped with 4 PT100 probes for temperature compensation. Measurement was performed, for both profiles, according to the following scanning measuring parameters:

- 3 Workpiece Orientations (WO): 0°, 90° and 210°;
- 5 Scanning Speed (SS): 2, 8, 14, 20, 24 mm/s;
- 3 Stylus Length (SL): 35, 135 and 235 mm;
- 3 scanning measure repetitions for each parameter set.









SL= 35mm, WO= 0° - EXTERNAL INVOLUTE PROFILE									
SS / mm s ⁻¹	f 1 / mm ⁻¹	λ ₁ / mm	A₁ / μm	f ₂ / mm ⁻¹	λ₂ / mm	A₂ / μm	f ₃ / mm ⁻¹	λ ₃/mm	A ₃ / μm
2	0.1286	7.777	4.799	0.4001	2.500	2.928	1.2430	0.804	0.857
8	0.1286	7.779	4.806	0.4000	2.500	2.935	1.2570	0.796	1.063
14	0.1286	7.776	4.799	0.4001	2.500	2.970	1.2574	0.795	0.993
20	0.1286	7.776	4.767	0.4001	2.499	3.069	1.2432	0.804	0.890
24	0.1286	7.777	4.779	0.4001	2.500	3.142	1.2430	0.804	0.873

External profile FFT results as function of SS

SS = 2 mm/s, WO= 0°- EXTERNAL INVOLUTE PROFILE										
SL / mm	f 1 / mm ⁻¹	λ₁ / mm	A₁ / μm	f ₂ / mm ⁻¹	λ₂ / mm	A₂ / μm	f ₃ / mm ⁻¹	λ ₃ / mm	A ₃ / μm	
35	0.1286	7.777	4.799	0.4001	2.500	2.928	1.2430	0.804	0.857	
135	0.1286	7.777	4.799	0.4001	2.500	2.936	1.2430	0.804	0.871	
235	0.1286	7.777	4.806	0.4001	2.500	2.932	1.2430	0.804	0.880	
	SS = 2 mm/s, WO= 90°- EXTERNAL INVOLUTE PROFILE									
SL / mm	f 1 / mm ⁻¹	λ₁ / mm	A₁ / μm	f ₂ / mm ⁻¹	λ ₂ / mm	A₂ / μm	f ₃ / mm ⁻¹	λ ₃ / mm	A ₃ / μm	
35	0.1286	7.775	4.781	0.4001	2.499	2.927	1.2432	0.804	0.865	
135	0.1286	7.776	4.770	0.4001	2.499	2.935	1.2432	0.804	0.873	
235	0.1286	7.776	4.770	0.4001	2.499	2.938	1.2431	0.804	0.915	
SS = 2 mm/s, WO= 210°- EXTERNAL INVOLUTE PROFILE										
SL / mm	f 1 / mm ⁻¹	λ ₁ / mm	A₁ / μm	f ₂ / mm ⁻¹	λ ₂ / mm	A₂ / μm	f ₃ / mm ⁻¹	λ ₃ / mm	A ₃ / μm	
35	0.1286	7.778	4.793	0.4000	2.500	2.934	1.2428	0.805	0.860	
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Uncertainty	significance level					
source	high	low				
Measurement repeatability		ν				
Measurement reproducibility	Ν					
CMM geometrical error (uncompensated)	Ν					
Sample centering	ν					
Probing effect		ν				
Algorithm of analysis	ν	V				
Scanning speed		ν				
Stylus length		ν				
Sample fixturing		ν				

135	0.1286	7.776	4.782	0.4001	2.500	2.930	1.2431	0.804	0.862
235	0.1286	7.776	4.772	0.4001	2.500	2.924	1.2431	0.804	0.891

External profile FFT results as function of SL and WO

Thermal drift	V
Sources to be taken into accou	nt for

uncertainty budget evaluation

Remarks/Conclusions

Freeform scanning on an internal involute profile measurement standard designed and manufactured by PTB has been conducted. Points to be outlined:

- the presence of unsuspected effects as eccentricity and some plausible thermal effects not deeply investigated, yet;
- a barely significant trend of the dependence of $f_{Ha}f_{Ha}F_{a}$, parameters as a function of SS,SL or WO; \bullet

high and stable performances of the machine from spectral analysis of data: evaluations of wavelength and amplitude are very repeatable and not influenced by WO, SS or SL; maintenance of high performances also at the most critical measuring conditions.

Acknowledgment:

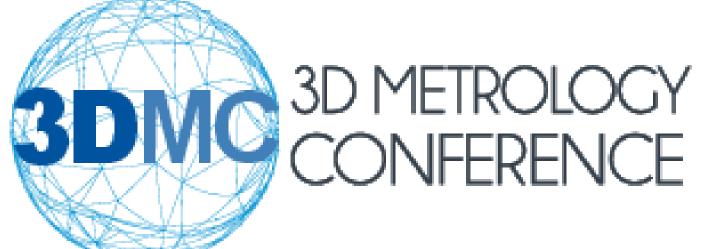
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https://www.ptb.de/emrp/eng56-home.html

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Example of internal involute measurement scanning

WO with respect to machine x-axis and y-axis (green)



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